



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
MINEO SHIMOTSUSA, ET AL.

Application No.: 10/657,269

Filed: September 9, 2003

For: SEMICONDUCTOR DEVICE,
METHOD FOR
MANUFACTURING THE
SAME, AND LIQUID JET
APPARATUS

Examiner: Long Pham

Group Art Unit: 2814

March 29, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated November 29, 2004, the period for response to which having been extended to March 29, 2005 by the accompanying Petition for Extension of Time with fee, please amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

March 29, 2005
(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310
(Name of Attorney for Applicant)


Signature

March 29, 2005
Date of Signature